



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/696,432 Confirmation No. 6825  
Applicant : Ying-Lang Wang  
Filed : October 29, 2003  
TC/A.U. : 2813  
  
Title : **CMP Process Leaving No Residual Oxide Layer or Slurry  
Particles**  
  
Docket No. : N1085-90131 (TS01-167CB)  
Customer No. : 08933

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**CERTIFICATE OF MAILING,  
37 C.F.R. §1.8(a)**

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22313-1450.

*Richard A. Paikoff*

Richard A. Paikoff, Reg. No. 34,852

4/12/06

Date

**AMENDMENT AND RESPONSE**

Sir:

In response to the Office Action of December 29, 2005, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 4 of this paper.